



Receipt
PATENT
29936/39482

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Kwak et al.

Serial No.: 10/617,269

Filed: July 10, 2003

For: Method of Forming an Isolation
Firm in a Semiconductor Device

Group Art Unit: 2818

Examiner: Not Yet Assigned

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[Signature]
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Attorney for Applicants

REQUEST TO CORRECT FILING RECEIPT

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Attn: Office of Initial Patent Examination's
Filing Receipt Corrections

Sir:

Applicants hereby request that a corrected Filing Receipt be issued in the above-identified patent application. Please correct applicant Cha Deok Dong's city of residence as indicated in red on the attached copy of the official Filing Receipt. The correct city of residence is Kyungki-Do.

Applicants additionally request that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Respectfully submitted,

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By:

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September 22, 2003



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APPL NO.	FILING OR 371 (c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/617,269	07/10/2003	2818	750	29936/39482	4	18	2

CONFIRMATION NO. 2479

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FILING RECEIPT



OC000000010808425

MARSHALL GERSTEIN

Date Mailed: 09/04/2003

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Applicant(s)

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Domestic Priority data as claimed by applicant

Foreign Applications

REPUBLIC OF KOREA 2002-40691 07/12/2002

If Required, Foreign Filing License Granted: 09/03/2003

Projected Publication Date: 01/15/2004

Non-Publication Request: No

Early Publication Request: No

Title

Method of forming an isolation film in a semiconductor device

Preliminary Class

365

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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